Process-parameter-dependent optical and structural properties of ZrO$_2$MgO mixed-composite films evaporated from the solid solution

N. K. Sahoo and A. P. Shapiro

The process-parameter-dependent optical and structural properties of ZrO$_2$MgO mixed-composite material have been investigated. Optical properties were derived from spectrophotometric measurements. By use of atomic force microscopy, x-ray diffraction analysis, and energy-dispersive x-ray (EDX) analysis, the surface morphology, grain size distributions, crystallographic phases, and process-dependent material composition of films have been investigated. EDX analysis made evident the correlation between the oxygen enrichment in the films prepared at a high level of oxygen pressure and the very low refractive index. Since oxygen pressure can be dynamically varied during a deposition process, coatings constructed of suitable mixed-composite thin films can benefit from continuous modulation of the index of refraction. A step modulation approach is used to develop various multilayer-equivalent thin-film devices.

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1. Introduction

In spite of all the modern technological advancements in coating processes and controls, the problem of identifying optimum optical materials for developing precision thin-film devices still remains. The use of conventional multilayer thin-film structures fails to meet the changeable, yet demanding, requirements of high-power laser, cryogenic, and space-based technologies. Especially in the case in which high-intensity electromagnetic radiation is present, the discrete refractive indices ($H$, $L$, $M$, etc.) result in multitransition in the electric-field amplitude within a multilayer stack. Alternatively, the most promising approach is to use continuously varying refractive-index and composition profiles, thus avoiding standing-wave electric-field distributions associated with discrete multilayer boundaries. The important inherent advantages of such configurations over multilayer filter stacks is the absence of discrete interface layers, often the source of light-scattering defects, and the increased design versatility due to the availability of a full range of refractive indices as opposed to limited discrete values.\textsuperscript{1,2}

In this study, we have studied the process-dependent optical and structural properties of mixed-composite ZrO$_2$MgO films deposited from the solid solution, and we have successfully achieved tunability of the refractive index. During the course of this investigation, we found an interesting dominant effect of oxygen pressure on the film's optical properties. In the higher range of oxygen pressure, we observed a dramatic lowering of refractive indices. Various kinds of optical inhomogeneities were also observed when different process parameters were systematically altered. Optical properties and constants have been derived from the transmittance and the reflectance spectra of the films recorded during and after the process. Through atomic force microscopy (AFM), the surface structures and power spectral densities (PSD's) of critical films have been investigated. Combinations of other characterization techniques, such as x-ray diffraction analysis and energy-dispersive x-ray (EDX) via scanning electron microscopy (SEM), provided much valuable information about the process-dependent microstructure of the films. Note that the refractive index of the
tions showed an initial homogeneous structure within the first few quarter-wave turning points (critical thickness) followed by a transition to inhomogeneity. An experimental film of this type, deposited at optimized temperature and at a high rate of evaporation, has been described in the sections below.

2. Earlier Research on Coevaporated Mixed Films
Tunability of the refractive index of mixed-material optical thin films has created significant interest in the area of thin-film coatings. It is possible to develop more complex multilayer thin-film devices by using a variable refractive-index material in the design. For example, through the controlled variation of refractive index with respect to layer thickness, optical coatings such as rugate filters, wide-band antireflection coatings, nonpolarizing beam splitters, and minus filters can be developed to the desired specifications in the best possible manner. Obtaining such optical properties experimentally, however, is quite intricate. The theoretical aspect of development of optical coatings with continuously varying refractive index has been investigated by Jacobsson in great detail. Although coevaporation has been tried by many thin-film researchers to achieve the tunability, the methodology is still not well developed. This is due to the complexity in the process control caused by the large number of deposition parameters that are required when independent sources are utilized. For example, there have been reports on the double electron-beam coevaporation of mixed films of $\text{ZrO}_2-\text{SiO}_2$, $\text{TiO}_2-\text{SiO}_2$, $\text{ZrO}_2-\text{Y}_2\text{O}_3$, $\text{ZrO}_2-\text{Al}_2\text{O}_3$, $\text{HfO}_2-\text{MgF}_2$, $\text{ZrO}_2-\text{Ta}_2\text{O}_5$, $\text{Ta}_2\text{O}_5-\text{SiO}_2$, $\text{In}_2\text{O}_3-\text{ZrO}_2$, $\text{ZrO}_2-\text{ZnO}$, and $\text{ZrO}_2-\text{MgO}$. In this approach it is possible to obtain a refractive index of the mixed film at any desired value between lower- and upper-index component values by suitably controlling the rate of evaporation of individual sources. This approach is quite involved, as the coating system has to be equipped with at least two different sources with necessary feedback controllers for measuring and controlling the dynamics of the deposition process.

Most recently, the potential of tuning optical and structural properties of solid solution composite materials has created a substantial interest in the development of advanced multilayer structures. The formation of solid solutions in semiconductors and dielectrics is important, since it very often leads to a material with quite new optical and physical properties.

### Table 1. Sellmier Coefficients for the Films Deposited at the Same Rate of Deposition (1 Å/s), Without Any Additional Oxygen, at Various Substrate Temperatures

<table>
<thead>
<tr>
<th>Sub. Temp in °C</th>
<th>Coefficient $A$</th>
<th>Coefficient $B_1$</th>
<th>Coefficient $B_2 \times 10^4$</th>
<th>Coefficient $C_1$</th>
<th>Coefficient $C_2 \times 10^8$</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ambient</td>
<td>1.0901</td>
<td>2.4601</td>
<td>2.135</td>
<td>18.633</td>
<td>5.76</td>
</tr>
<tr>
<td>125</td>
<td>2.3476</td>
<td>1.3644</td>
<td>3.0728</td>
<td>32.7578</td>
<td>5.76</td>
</tr>
<tr>
<td>167</td>
<td>2.1834</td>
<td>1.7316</td>
<td>2.8032</td>
<td>2.707 × 10⁻⁸</td>
<td>5.76</td>
</tr>
<tr>
<td>239</td>
<td>2.0743</td>
<td>1.7372</td>
<td>2.7796</td>
<td>1.3733 × 10⁻⁷</td>
<td>5.76</td>
</tr>
</tbody>
</table>

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Recently, the optical structural properties of solid solutions of ZnSe, Te$_{1-x}$ have been investigated by El-Nahass et al., with the goal of developing photoelectronic devices. It has been established that some of the refractory oxides and rare earths, e.g., ZrO$_2$, Sc$_2$O$_3$, MgO, In$_2$O$_3$, Al$_2$O$_3$, Y$_2$O$_3$, and CaO, exhibit extended solid solubility among themselves. These mixed-material solid solutions have phase-transformation temperatures and a whole range of new optical, physical and structural properties that are substantially different from those of the individual pure materials. Formation of a solid solution of this sort, however, is possible only among specific crystallographic phases of the oxides. These solid solutions in composite materials are very important for optical-coating applications because of their potential for having tunable properties by means of process modulation.

3. Earlier Research on the ZrO$_2$-MgO System

Historically, the ZrO$_2$-MgO binary system has drawn the attention of so many investigators because of its potential use in structural and corrosion-resistant applications. Magnesia partially stabilized ZrO$_2$ is the toughest monolithic ceramic now known. Although some optical-coating studies have already been reported on for coevaporated ZrO$_2$ + MgO mixed films, not much research has been done on its solid solution. Various studies have already been carried out on the equilibrium phase relations in the binary ZrO$_2$ + MgO system. Several investigations have reported metastable tetragonal or cubic zirconia following the decomposition of unstabilized and stabilized zirconium-based precursors at temperatures well below that which the stable modifications are known to exist. Ruff and Ebert reported that the two oxides ZrO$_2$ and MgO combined to form a cubic phase above 1460°C. They considered the cubic phase to be a compound having the formula Mg$_2$Zr$_3$O$_{12}$; however, it was later established that ZrO$_2$ and MgO form a limited series of solid solutions rather than a compound. It has also been observed that the probability of MgO forming a solid solution with monoclinic ZrO$_2$ is very limited.

During our investigations, we discovered the traces of monoclinic phase in the films deposited in certain ambient conditions. The microstructural development during the aging of supersaturated solid solutions of cubic ZrO$_2$ stabilized with MgO has been studied by Porter and Heuer using transmission electron microscopy. They observed a very interesting stress-induced transformation leading to a high-fracture toughness during the annealing experiments. The formation of a defect phase Mg$_2$Zr$_3$O$_{12}$ within the cubic matrix at a temperature of 1250°C has been reported by investigators. With respect to optical-coating applications, however, it is observed that the cubic phase of ZrO$_2$ yields the most favorable optical properties. Studies of MgO-stabilized zirconia optical coatings prepared by double-electron-beam gun evaporation on nickel substrates by Tcheliebou et al. have shown an interesting result: They obtained a refractive-index maximum from the samples contain-
ing 15% (molar) MgO in the alloy. At molar percentages of MgO greater than 20%, a monotonic decrease of index and packing density was noted. Similar composition-dependent optical properties were observed in our investigation during optimization of the process parameters for our samples.

4. Experimental Details

We deposited mixed-composite films on 25-mm-diameter, 3–5-mm-thick, optically polished quartz and BK7 substrates by evaporating optical-grade ZrO$_2$:MgO solid solution typically 99.7% pure (M/s CERAC Inc., supplied). The deposition chamber used throughout this investigation was a Balzers BAK-760 fully automatic box coater, cryopumped to a base pressure of 8 × 10$^{-7}$ mbar. The material was evaporated from a Temescal CV-8 four-pocket electron-beam source. During the deposition, we controlled the beam position and the scanning manually for the best utilization of the surface of the evaporating material. In this chamber, the substrates can be heated as high as 300 °C by a pair of quartz lamps. The temperature can be controlled by a Eurotherm controller with a repeatability of ±1 °C. The substrates can be preheated or postheated to the desired level by the Balzers BPU-420E process controller. Note that it is difficult to measure the temperature of the rotating substrate during the actual process. We found it necessary to determine a scaling factor experimentally to derive the actual temperature of the substrate from the temperature measured by means of a thermocouple located above the heating sources. For this calibration, we mounted a large piece of plate glass (59 cm × 45 cm) on our rotary planetary and placed the thermocouple in contact with this substrate during rotation. We then measured the equilibrium temperatures achieved as a result of different heat-lamp power settings. The same steps were repeated with the thermocouple located at the measuring position near quartz lamps, and a calibration curve was generated between two sets of measurements. The thermocouple for the Eurotherm controller was precalibrated with the freezing and the boiling points of water.

A fully automatic advanced Balzers GSM-420 optical monitor–controller was used to control and monitor the optical thickness of the growing films. It is also possible to use this system as an in situ spectrophotometer over the UV to the near-infrared (NIR) spectral range. Hence the spectral characteristics of the deposited film can be recorded both during and after the deposition and also either inside or outside the vacuum. A Balzers QM-420 six-head quartz-crystal controller was used to control either the physical thickness or the rate of evaporation of the films. The oxygen pressure can be very accurately controlled by a Balzers Model RV-420 mass-flow controller.

During this investigation, the transmittance and the reflectance spectra of the films were recorded with a GSM-420 optical controller during and just after the deposition process. The postdeposition transmittance characteristics in air were recorded with a Perkin–Elmer Lambda-19 UV–vis–NIR spectrophotometer. The extent of inhomogeneity during the growth of film was computed from the in situ transmittance data. By use of SPECTR analysis software, developed by Sahoo, the films were characterized for their mean refractive index ($n_m$), extinction coefficient ($k_m$), absorption constant ($\alpha_m$), physical thickness ($d$), and inhomogeneity ($\Delta n$). The phase compositions of films deposited in various process conditions were analyzed through x-ray diffraction. The semiquantitative compositions of the films grown in varying deposition conditions were determined by SEM.
5. Spectrophotometric Analysis

There have been several reported efforts to extract the optical constants of inhomogeneous thin films from spectrophotometric data. 29-33 It is now very well accepted that there is always some ambiguity involved in the determination of the constants when only postspectrophotometric measurements are taken into account, especially for nonlinear inhomogeneous films. Fortunately, in situ transmittance and reflectance data recorded during the growth of such films may be used to provide the vital information necessary for accurate computation of desired constants. In general, transmittance measurements are more accurate than reflectance. 34, 35 Borgogno et al. 36 have described the limitation of accuracy obtained during the monitoring of inhomogeneous multilayer systems. A novel technique based on transmittance measurements carried out in vacuum has been developed by Bovard et al. 30 to derive the dispersive refractive-index profile and extinction coefficient of inhomogeneous thin films. They used a rapid-scanning monochromator system during the deposition process.

In our present studies, we recorded the transmittance signal at a predetermined wavelength during the growth process, and we scanned the film transmittance in vacuum after the deposition from 350 to 975 nm using the of GSM-420 optical monitor system. Both of these data sets were used in combination with spectral characterizations acquired after exposure to room air at ambient humidity to analyze the inhomogeneity and to determine optical constants. The latter transmittance spectra were recorded on a Perkin-Elmer Lambda-19 UV-vis-NIR spectrophotometer. All spectra were then analyzed to locate their interference peaks using SpectraCalc commercial data-analysis software. The spectrophotometric data sets were then processed by the SPECTR Calc commercial data-analysis software. The optical constants of inhomogeneous thin films were then fit very well by use of the two-pole Sellmeier dispersion formula 39:

\[ n_m^2(\lambda) = A + B_1(1 - B_2/\lambda^2) + C_1/(1 - C_2/\lambda^2), \]  (4)

where \( \lambda \) is the wavelength of the incident light and coefficients \( A, B_1, B_2, C_1, \) and \( C_2 \) have their meanings as per Ref. 39. The first and second terms represent, respectively, the contribution to refractive indices due to higher-energy and lower-energy bandgaps of electronic absorption, whereas the last term accounts for a decrease in refractive indices because of lattice absorption. Subsequently, these index fits were refined to match the computed transmittance spectra with experimental curve to a reasonably good accuracy. It is also possible to compute mean electronic bandgaps (\( E_p \)) from the Sellmeier coefficient \( B_2 \). In the above expression, the coefficient \( C_2 \) determines the IR transmission cutoff; it is the square of twice the energy associated with the IR transmission cutoff edge. The computed Sellmeier coefficients for samples prepared under various substrate temperatures but at the same rate of deposition and oxygen pressure are given in Table 1.

Like refractive index, the mean extinction coefficient for inhomogeneous films is defined as

\[ k_m = \int_0^d k(z)dz. \]  (5)

In the present case, we computed the extinction coefficients in strong and medium absorbing regions...
Fig. 6. Bandgaps of films deposited under different substrate temperatures but at the same rate (1 Å/s) and oxygen pressure (base value). Film deposited at ambient temperature shows an additional indirect bandgap (corresponding to o-phase), which is shown in the inset plot.

using \( T_a \) and \( T_i \), which are the geometric and arithmetic means of \( T_M \) and \( T_m \), and are defined as:

\[
T_a = \sqrt{(T_M T_m)},
\]

\[
T_i = 2T_M T_m/(T_M + T_m).
\]

Variables \( T_M \) and \( T_m \) are the maxima and the minima transmittance envelopes, respectively, for the interference fringes as shown in Fig. 1. Subsequently, the values were fitted with a suitable equation to compute the constants in the weakly absorbing and transparent region. For our films we found that the extinction coefficients follow a logistic equation very well, which is as follows:

\[
k_m(\lambda) = \frac{a}{1 + (\lambda/c)^b},
\]

where \( \lambda \) is the wavelength of light and \( a, b, \) and \( c \) are the coefficients for fitting.

Besides refractive-index and extinction coefficients, the optical bandgap energy, \( E_g \), provides very important information regarding the spectral range over which the desired optical material is useful. Optical absorption edges are not perfectly sharp for dielectric and semiconducting materials. Hence it is necessary to examine more carefully the nature of the absorption process to understand their shapes. Such understandings provide information on the stoichiometry and the phase composition of the material. For a direct bandgap the absorption coefficient for transitions is of the form:

\[
\alpha \sim [\hbar \omega - E_g]^{1/2},
\]

for \( \hbar \omega > E_g \),

\[
\alpha = 0,
\]

for \( \hbar \omega < E_g \), and for indirect transitions:

\[
\alpha^{1/2} \sim [\hbar \omega - E_g],
\]

for \( \hbar \omega > E_g \) where \( \alpha \) is the absorption constant and \( \hbar \omega \) (or \( \hbar \nu \)) is the photon energy of the incident radiation.

In the present case, the process-dependent bandgap values provided very useful information with regard to the phase composition of the films deposited in specific deposition conditions.

6. Films with Mixed Inhomogeneity

During our experiments we discovered that in certain process conditions the films showed mixed inhomogeneity, i.e., after certain minimum critical thickness of homogeneous growth, the inhomogeneity began to appear. This phenomenon is observed during in-process optical monitoring. The presence of such a structural condition is also reflected in the postprocess transmittance spectra. In the transmittance spectra, the peak minima show a modulative behavior instead of being dispersive. An experimental ZrO\(_2\)MgO film, deposited at a substrate temperature of 125 °C, at a rate of 3 Å/s, and without any additional oxygen, is depicted in Fig. 2.

The computation of optical constants requires much more complex modeling when inhomogenous or mixed growth modes are present. The simulated refractive-index profile and the corresponding calculated transmittance curve for our experimental ZrO\(_2\)MgO film are shown in Fig. 3. This spectral characteristic is simulated with a combination of homogeneous and inhomogeneous growth models. We divided the entire thickness of the layer to 20 small discrete sublayers to model the index profile. Dis-
structure in sputter-deposited MgO films. They observed an increase of dielectric permittivity by 40% of bulk value in such films. The presence of MgO in the solid solution deposited in specialized conditions in our experiment may be related to the observed inhomogeneity.

7. Effect of Substrate Temperature
The substrate temperature was found to have a significant effect on the film optical constants. The films prepared in ambient conditions, i.e., at base vacuum pressure and without quartz lamp heating, exhibited the lowest refractive index as shown in Fig. 4. The maximum index was obtained with a depo-

Fig. 9. Extinction coefficients of films deposited under different oxygen pressures but at the same rate (1 Å/s) and substrate temperature (125 °C).

Fig. 10. Bandgaps of films deposited under different oxygen pressures but at the same rate (1 Å/s) and substrate temperature (125 °C).

Fig. 8. (a) Air-to-vacuum shift of the refractive index of the film deposited at the higher oxygen pressure of 8 × 10⁻⁴ mbar. (b) Measured transmittance characteristics of the film deposited at high oxygen pressure (8 × 10⁻⁴ mbar) in vacuum and in air.

dispersion in refractive index and extinction coefficients are not taken into account to avoid the complexity in the computation. The simulated refractive-index profile shows a highly nonlinear behavior after a certain critical thickness of homogeneous growth. More detailed analyses on these aspects are being carried out and will be reported soon. This type of mixed nonlinear inhomogeneity has also been reported by Tikhonravov et al. in their study of the refractive-index profile of ZrO₂ films with a fast-scanning acousto-optic spectrophotometer.

A growth-dependent stoichiometry, which appears in oxygen-rich polycrystalline MgO films, has been reported by Hebard et al. They discovered that a rapid increase of oxygen enrichment beyond a certain critical thickness gives rise to a superstoichiometric fraction.
sition temperature of 167 °C, but beyond this value, the index variation showed a downward trend. The inhomogeneity in the films also showed a quite significant change from positive to negative as a function of substrate temperature. The films prepared at ambient conditions showed positive inhomogeneity and, at our highest deposition temperature of 239 °C, they showed negative inhomogeneity. With a temperature of 125 °C, films showed relatively better homogeneous behavior. This effect is depicted in Fig. 1. It is at this optimum temperature condition that we varied the oxygen pressure to study additional changes in the optical properties.

There is an additional interesting result regarding extinction coefficients in these films. It can be concluded from Fig. 5 that the mean extinction coefficients showed minimum values for the films deposited at ambient temperature. Bandgap analysis in the case of pure ZrO₂ shows very interesting results. A reported analysis on joint density states of various phases in ZrO₂ has revealed a double-peaked feature near the absorption edge, implying that there are more than one direct near-edge transitions. Per our bandgap analysis, the composite films showed an indirect bandgap at 4.41 eV in addition to a direct gap at 4.62 eV, as shown in Fig. 6. A previous band-structure calculation on α-ZrO₂ predicts an indirect gap at 4.51 eV close to one of our experimental values of 4.41 eV. This implies that there is a small amount of monoclinic phase present in that deposition condition. This aspect is subsequently confirmed by x-ray diffraction analysis.

8. Effect of Oxygen Pressure

For oxide films, the oxygen pressure during the growth process controls the stoichiometry of the structure. The influence of oxygen concentration on optical properties of semi-insulating polycrystalline silicon films has been studied by Kucírková et al. They observed a very pronounced effect of oxygen content on optical constants of the films. During our current experiments, oxygen pressure also showed the most dominant effect on the optical constants. The highest refractive indices were obtained at a pressure of 1 × 10⁻⁴ mbar as shown in the Fig. 7. As the pressure during deposition was increased, however, the indices rapidly decreased. When the pressure was increased to 8 × 10⁻⁴ mbar, the film indices decreased to a value as low as the substrate indices if observed inside the vacuum. When such films were

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Fig. 11. Refractive indices of films deposited under different rates of evaporation but at the same oxygen pressure (base value) and substrate temperature (125 °C).

Fig. 12. Extinction coefficients of films deposited under different rates of evaporation but at the same oxygen pressure (base value) and substrate temperature (125 °C).

Fig. 13. Plot of PSD of uncoated quartz substrate versus spatial frequency showing a quasi-linear behavior.
exposed to air, a large change in the index, indicative of a low packing density in the films, was observed. The vacuum-to-air transition of refractive index has been presented in the Fig. 8(a). It is also observed that such a transition can be minimized by sealing this portion of the layer with the subsequent deposition of a layer without any additional oxygen (i.e., higher packing density) and this leads to a more stable characteristic in air. This aspect was demonstrated by the successful development of a steep-edge filter. The sharp variation of refractive indices of the composite films over the higher end of the oxygen pressure scale tested gave us the idea of modulation.

Effects of oxygen pressure on pure ZrO₂ films have been investigated by several experimentalists. 40,46-50 It has been observed that these films are inherently rich with oxygen. When such films are deposited in an oxygen atmosphere, the excess oxygen embedded in the films yields superstoichiometric ZrO₂₋ₓ. Observations of these structures, primarily based on analysis of x-ray photoelectron spectroscopy, are reported by Khawaja et al. 47 They attributed this to be the cause of the lower refractive index at higher oxygen pressure. Similar experiments on MgO have generated a wide variety of results, with reports of films containing an excess of oxygen as much as 40%. The presence of excess oxygen in these films also generates a superstoichiometric MgOₓ (x > 1) composition with high dielectric strength. 44,53 Likewise, in our experimental ZrO₂MgO composite films,
the affinity for the oxygen has generated the interesting effect of causing a reduction of the mean refractive index down to a substrate value. These films showed highly negative inhomogeneity during their growth. Typical transmittance spectra taken just after the growth of the film in vacuum and then in air are presented in Fig. 8(b). It is clear that in air, the formerly highly inhomogeneous film becomes completely homogeneous with a sharp increase in the refractive index. This implies a poor packing density in the film.

The mean extinction coefficients showed an identical trend with respect to oxygen pressure. Samples prepared at $1 \times 10^{-4}$ mbar displayed the minimum optical losses as shown in Fig. 9, and samples prepared at $6 \times 10^{-4}$ mbar displayed the highest extinction coefficients. Similarly, as shown in Fig. 10, the

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Effect of Rate of Evaporation

The rate of evaporation somewhat affected the films constants. Films prepared at a higher rate of evaporation showed relatively lower refractive index and higher extinction coefficients, as shown in Figs. 11 and 12. It is likely that the slower rate allows for a better stabilization of the nucleation process through a higher relaxation time, which, in turn, gives rise to a higher packing density and improved indices. The most interesting effect observed in high-rate deposited films is the very prominent transition from homogeneous to inhomogeneous structures. Such a change was clearly observed during the in situ optical monitoring. The peak minima in the posttransmittance spectra also showed very different modulation behavior, as shown in Fig. 2. This effect was simulated assuming the presence of both homogeneous and inhomogeneous structures in the films along the growth direction, as depicted in Fig. 3.

Atomic Force Microscope Analysis

We used AFM for both qualitative as well as quantitative investigation of process-dependent properties. In these analyses, the morphological features, together with the roughness, can be acquired simultaneously over a wide range of spatial frequencies. The equipment used for this portion of our investigation consisted of a Topometrix TMX 2000 series atomic force microscope. The probes used for the scans are standard Si$_3$N$_4$ pyramidal tips (1:1 aspect ratio, $4 \mu m \times 4 \mu m$) with triangular levers and 0.032-N/m spring constants.

For evaluating surface roughness, the current standard procedure is to use the PSD for topography description. The statistical PSD function is defined as the square magnitude of the Fourier transform of the surface profile; it provides pertinent information concerning the amplitude of the surface features as a function of lateral spatial frequency. Even for high-quality samples, a few localized defects (~1-μm radius) may still be present on the surface and produce a nonrandom spectrum. Although these defects may be rather far (~50 μm) from one another, by coincidence the atomic force microscope tip may get positioned near one or more such defects, resulting a nonrandom spectrum. It is essential to point out that, in the presence of local defects, the nonrandom roughness can be predominant and alter all AFM analysis of random roughness. In such cases, the use of analysis software is absolutely necessary to eliminate such points before determining the random roughness.

For uncoated quartz surfaces, the roughness spectrum follows approximately a straight line over several frequency decades on the log-log plot displayed in Fig. 13. This quasi-linear behavior of the PSD on a log-log scale is characteristic of a frequency variation given by:

$$\gamma(\sigma) = \frac{\phi}{\sigma^\psi} = \frac{\phi}{\sigma^\psi}, \quad (12)$$

where $\phi$ is a constant, $\sigma$ is the spatial frequency, and $\psi$ is the spectrum slope. Depending on whether the parameter $\psi$ is greater or lower than 2, the surface may appear rougher or smoother as the wavelength increases. For typical smooth surfaces this value is very close to 2. Such a power law may be characteristic of a fractal behavior of roughness or more specifically self-affine behavior. In this situation we calculate expression of the two-dimensional fractal dimension $D$ as a function of spectrum slope:

$$D = \frac{8 - \psi}{2} = \frac{[4\rho - \psi]}{2}, \quad (13)$$
Fig. 21. X-ray diffraction peaks of a 15-quarter-wave oxygen-modulated film. The inset plots show oxygen pressure variation with respect to the physical thickness and the measured reflectance spectrum of the coating.

where \( p \) is the dimensional parameter. The parameter \( D \) is quite informative in the case of AFM analysis; it describes how the roughness fills the space. The smoother the surface, the higher its \( D \) value. We obtained a value of 2.85 (\( \psi = 2.3 \)) for our bare quartz substrates, which means that our starting surface is reasonably smooth for the film deposition.

Surface topography of films deposited with oxygen pressure of 1 and \( 8 \times 10^{-4} \) mbars are presented in Figs. 14(a) and 14(b), respectively. As can be seen from these figures, the roughness and grain size of the films show maximum values for the films deposited at high oxygen pressure (average roughness, 45.21 nm). Films deposited at the optimum oxygen pressure of \( 1 \times 10^{-4} \) mbar showed a minimum average roughness of 7.53 nm. Deposition temperature alterations also produced very interesting changes in the surface topography. As can be seen from Figs. 14(c) and 14(d), films prepared at the maximum experimental temperature of 239 °C showed a quite smooth surface (9.37 nm) with more packed grains in comparison with the films prepared in ambient conditions (14.38 nm). In Fig. 15, the surface morphology of quartz substrate is depicted, which shows an average rms value of 0.834 nm over 20 \( \mu \)m \( \times \) 20 \( \mu \)m scan size.

It is also possible to obtain information on relative grain size from the cutoff frequencies of the PSD.\(^{55}\) In the case of PSD curves for thin-film samples, the spectral slope changes quite predominantly from a low to a high value and this point is designated as the cutoff frequency for the corresponding sample. It has already been established by Deumié et al.\(^ {54}\) that, in the case of thin-film samples, the variation in cutoff frequency is inversely proportional to the crystallite or grain size.\(^ {54}\) We also observed an identical trend in our samples. The samples deposited under high oxygen pressure showed larger grain size, which also can be observed in the PSD plots as shown in Fig. 16. The presence of additional small peaks at
ZrO$_2$MgO Thin Films on Quartz Substrate
Quartz Blank
Analyst: Coston  
keV: 10.00  Current: 0.50  Live Time: 100.00  eV/Channel: 10.00
Detector Resolution: 145.00 eV  Take-off angle= 35.00

Fig. 23. EDX analysis of the uncoated quartz substrate.

ZrO$_2$MgO Thin Films on Quartz Substrate
MCF-7
Analyst: Coston  
keV: 10.00  Current: 0.50  Live Time: 100.00  eV/Channel: 10.00
Detector Resolution: 145.00 eV  Take-off angle= 35.00

Fig. 24. EDX analysis of the film deposited under ambient substrate temperature and at a rate of 1 Å/s and oxygen base pressure. The relative peak heights for Zr:Mg:O are 1:0.175:0.178.
Fig. 25. EDX analysis of the film deposited at a substrate temperature of 167 °C and at a rate of 1 Å/s and base oxygen pressure. The relative peak heights for Zr:Mg:O are 1:0.152:0.211.

Fig. 26. EDX analysis of the film deposited under the highest experimental substrate temperature of 239 °C and at a rate of 1 Å/s and base oxygen pressure. The relative peak heights for Zr:Mg:O are 1:0.081:0.135.
higher spatial frequency in these plots is indicative of local defects. It can be seen from these characteristics that the prevalence of such defects is a minimum for the films deposited at base oxygen pressure. In Fig. 17, we have presented the data in a threedimensional form that clearly shows the sharp changes in the surface as a function of oxygen pressure in the high-pressure region. The decrease in the refractive indices at higher oxygen pressure can be attributed to a lowering of the packing density in the deposited films.

Atomic force microscope images also provided some qualitative information on the inhomogeneity in films. The samples with negative inhomogeneity (refractive indices decrease from the substrate-to-air interfaces) showed growth of crystallites that are more conical. This is evidence that these films are more densely packed and have a higher index of refraction near the substrate interface. The coated samples that were characterized as having negative inhomogeneity have optical transmission values at the half-wave turning points that exceed that of the bare substrates. The negative inhomogeneity in the films effectively produces a wide-band antireflection effect.

11. X-ray Diffraction Analysis

X-ray diffraction analysis of the samples grown with varied deposition parameters reveals very interesting differences in crystallographic phase andorientations of observed polycrystalloids. The diffraction spectra were recorded on a Rigaku (USA) diffractometer with Cu(Kα) (λ = 1.5418 Å) radiation. The angular resolution for each sample was 0.02°. Since the films were deposited on quartz, the short-range order of SiO₂ contributes to the background structure, especially in the lower 2θ region.

Substrate temperature and oxygen pressure induced more significant changes compared with the rate of deposition. Except in the case in which coatings were deposited at ambient temperature, the cubic-phase peak was dominant, but the crystallographic orientation varied as deposition parameters were changed. The 2θ positions of the cubic-phase

**Table 3. Relative SEM Peak Height Ratios of Zr:Mg:O for Various Sample Films Deposited under Different Process Conditions**

<table>
<thead>
<tr>
<th>Sub. Temp in °C</th>
<th>O₂ Pressure in mbar</th>
<th>Rate of Evap. Å/s</th>
<th>Zr:Mg:O (Relative Ratio)</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ambient</td>
<td>No Additional O₂</td>
<td>1.0</td>
<td>1:0.175:0.178</td>
</tr>
<tr>
<td>259</td>
<td>No Additional O₂</td>
<td>1.0</td>
<td>1:0.081:0.135</td>
</tr>
<tr>
<td>167</td>
<td>No Additional O₂</td>
<td>1.0</td>
<td>1:0.152:0.211</td>
</tr>
<tr>
<td>125</td>
<td>1.0 × 10⁻⁴</td>
<td>1.0</td>
<td>1:0.127:0.228</td>
</tr>
<tr>
<td>125</td>
<td>8.0 × 10⁻⁴</td>
<td>1.0</td>
<td>1:0.106:0.310</td>
</tr>
</tbody>
</table>
peaks very well matched those reported by Duwez and Odell for magnesia-stabilized cubic-zirconia samples. Samples prepared in ambient temperature conditions showed the presence of a very weak cubic phase in the films along with a trace of monoclinic phase as shown in Fig. 18. At a temperature of 239 °C, the film shows a very distinct cubic structure with the most preferred orientation being the (111) direction. For intermediate temperatures (167 °C and 125 °C), the most preferred orientation for crystalloids changed to the (200) direction. Note that in these phase conditions, the films had higher mean refractive indices and less inhomogeneity.

Since the films showed minimum inhomogeneity at a substrate temperature of 125 °C, we attempted to minimize the inhomogeneity further by varying the oxygen pressure. Regardless of the oxygen pressure used, the films grew with the (200) direction being the most preferred orientation, as shown in Fig. 19. For films grown at a oxygen pressure of $8 \times 10^{-4}$ mbar, the crystallographic peaks were essentially absent, implying extreme randomness in the orientations of the crystallites. This is the condition that gave the lowest possible refractive indices of the films. Changes in the rate of evaporation also caused very distinct variations in the amplitudes of diffraction peaks, and this was most likely due to differences in the size and the orientation of the crystalloids. In Fig. 20, a comparison of peak amplitudes for films evaporated at rates of 1 Å/s and 3 Å/s are displayed.

Oxygen-pressure-modulated films showed the presence of the cubic structure very prominently. For example, Table 2 reports the position of the cubic
peaks for 15-quarter-wave, oxygen-modulated film along with the reported peaks for the magnesia-stabilized (13.8 mol. %) ZrO₂ (cubic) peaks. Figure 21 shows the diffraction pattern of this film in addition to the measured spectral reflectance and oxygen modulation along the growth direction.

For this modulated sample, we tried to find the effective residual strain and particle size from the x-ray peak broadening. Two major contributions for the peak broadening, effective particle size and strain, can be expressed in the following equations (for the isotropic case):\(^{5,6,2,63}\):

\[
\frac{\beta}{\lambda} = \frac{1}{P \cos(\theta)} + \frac{4\varepsilon \tan(\theta)}{\lambda}, \quad (14)
\]

\[
\frac{\beta \cos(\theta)}{\lambda} = \frac{1}{P + 4\varepsilon \sin(\theta)/\lambda}, \quad (15)
\]

where \(\beta\) is the full width at half-maximum (FWHM) of the Bragg peaks in radians, \(\theta\) is the Bragg angle, \(P\) is the effective coherent diffraction center size, \(\varepsilon\) is the effective strain, and \(\lambda\) is the wavelength of the x-rays. For distorted or anisotropic lattices, the equation becomes more complex. The fact that stress-induced diffraction peak broadening follows a \(\tan(\theta)\) function, whereas the diffraction center size broadening has a \(1/\cos(\theta)\) dependence, allows us to separate these effects graphically. From the above relationship, the diffraction center size and the strain are obtained when \(\beta \cos(\theta)/\lambda\) versus \(\sin(\theta)/\lambda\), which is depicted in the Fig. 22, is plotted. The value of \(P\) computed from the intercept is \(-10\ \text{Å}\). The slope of this plot is nearly zero, which suggests that such a film is almost strain-free.

Films deposited at two different rates of evaporation showed very distinct changes in x-ray diffraction peak heights and widths, as shown in Fig. 20. At the higher rate, the peaks are smaller, which is indicative of additional stress present in the film. This may be due to the rapid nucleation process with minimum relaxation time that occurs during higher-rate evaporation. Alternatively, there are several other possible explanations for the microstress in polycrystalline films that include dislocations, vacancies, defects, shear planes, thermal expansions, and contractions.

**12. Energy-Dispersive X-Ray Compositional Analysis**

To determine the cause of large variation in the refractive index in films prepared under relatively high oxygen pressure, we tried to investigate the variation in composition among the samples. Other investigators have pointed out that the relative amount of MgO in ZrO₂ substantially affects the optical and the structural properties. To measure the relative amount of Zr and Mg in the samples, we performed relative compositional analysis using the EDX feature available in a Hitachi SEM, Model S-4000. The electron-beam energy used was 10 KeV with a detector resolution of 145 eV. The carbon peak at 0.25 KeV is the usual peak associated with hydrocarbon contamination nearly always present on samples introduced from the laboratory environments. In Fig. 23, the EDX analysis of the uncoated quartz substrate is presented.

The ratio of the peak heights for the elements Mg and Zr provided very interesting information regarding the composition. The zirconium-to-magnesium ratio changes in the films deposited in different conditions, even though they all are evaporated from the same bulk material (Figs. 24–28). The detailed relative compositional ratios of Zr, Mg, and O₂ in various process conditions are presented in Table 3. The samples prepared at the highest substrate temperature shows the minimum amount of Mg with 1:0.081:0.135 as the ratio of Zr:Mg:O. The sample prepared at the highest oxygen pressure showed a relatively higher oxygen peak height although magnesium...
Fig. 32. Design and measured transmittance characteristics of a single-layer broadband antireflection coating produced by oxygen modulation. The inset plot shows the oxygen modulation with respect to the physical thickness of the layer.

peak was small. This can be attributed to the presence of water vapor in the film voids. The samples prepared at a temperature of 167 °C have the highest refractive index with a relative composition of 1:0.152 for Zr:Mg. In Fig. 29 we have plotted the mean refractive index with respect to both normalized magnesium and oxygen quantities. It can be seen from this plot that the highest mean refractive index, 2.023, has been obtained at an optimum magnesium (0.152) and oxygen (0.211) amount in the sample. This implies that an optimum level of MgO in the film produces a maximum value of the mean index. This observation is very interesting as a similar kind of compositional behavior has been reported by Tcheliebou et al. for their coevaporated mixed ZrO₂MgO films. Their study shows that it is possible to obtain the highest refractive index from mixed films that contain 15% mol of MgO, which is very much similar to our observation in the case of our solid solutions.

The possible explanation for the change in the ratio of zirconium to magnesium in samples prepared in different process conditions may be due to different nucleation and growth kinetics of the two constituent oxides (ZrO₂ and MgO) present in the solid solution. It is well known that refractory oxides, when deposited by electron-beam gun, first decompose and then recombine at the substrate. Since these two constituent oxides have different melting points, the corresponding accommodation coefficients (α_r), which is defined below, will be different.

\[
α_r = \frac{(t_i - t_e)}{(t_i - t_s)},
\]

where \( t_i \) is the temperature of the incident atoms, \( t_e \) is the temperature of atoms reevaporating from the substrate, and \( t_s \) is the temperature of the substrate. Similarly, the associated sticking coefficient and surface diffusion will be different for the two species depending on the oxygen pressure and the substrate temperature used during the deposition process, which effectively control the extent of oxidation as well as nucleation at the substrate surface. In our case, this probably led to a different ratio of zirconium and magnesium observed in different process conditions.

13. Results and Applications

The effects of various process parameters on optical properties were analyzed in depth. It was found that the refractive index strongly depends on both oxygen pressure and substrate temperature. The rate of evaporation has a relatively less dominant effect on optical properties. The substrate temperature controls the homogeneity of the films. At lower temperatures, the films were negatively inhomogeneous and at higher temperatures the films became positively homogeneous. The mean values for
refractive indices also changes with temperature, being highest at a value of 167 °C. At a temperature value of 125 °C, the films showed minimum inhomogeneity, although the mean refractive index was lower compared with the value at 167 °C. It is at this particular temperature that we varied the oxygen pressure. It was observed that the optical constants improved at a particular value of oxygen pressure. On both sides of this value, the constants deteriorated. The most significant change occurred when the pressure was below 2 × 10⁻⁴ mbar. Here the index changes appreciably with the pressure. At oxygen pressure 6 × 10⁻⁴ mbar, the films behave like medium index materials. At a value of 8 × 10⁻⁴ mbar, however, the values almost matched the substrate values. This interesting change has enabled us to develop multilayer-equivalent-thin-film systems using the oxygen-modulated-single-film material. Unlike substrate temperature, oxygen pressure has the advantage in that it can be tuned quite rapidly during the deposition process. Hence one can achieve a continuously varied refractive in this material by suitably varying pressure during processing.

We have successfully developed various multilayer equivalent optical coatings using step modulation of oxygen during the growth of the film. In Fig. 21, we have presented the experimental characteristics of an oxygen-modulated 15-quarter-wave-thick film, which has a peak reflectance value of ~90% and a FWHM of 800 nm. The oxygen pressure modulation versus optical thickness of the film is also depicted below this plot. Similarly, using an optical thickness of 34 quarter waves in the film and suitably controlling the timings of modulation, we were able to generate characteristics of an edge filter equivalent to the design 0.5H (LH) × 16 L 0.5H. The characteristics of such a single-layer coating is presented in Fig. 30. The oxygen pressure modulation versus layer thickness is also presented in this figure. Note from this experimental characteristic that the edge filter has a stop band over 495–545 nm and a passband with good ripple rejection starting from 565 nm. It carries a sharp transition in the reflectance that makes the coating an excellent wavelength multiplexer for use with closely spaced wavelengths. We have observed that, because of the change of refractive indices, there is a change of spectral characteristics measured in air and vacuum. In Fig. 31, we have presented the measured characteristics of an experimental edge filter in air and in vacuum. It can be observed from this plot that the characteristic in air has shifted to higher wavelengths with a decrease in reflectance over the stop band. This clearly indicates the increase of refractive index in the oxygen-enriched portion of the layer when exposed to air. In Fig. 32, we have shown the experimental characteristics of a more difficult antireflection coating. It has been observed in several modulated films that the vacuum-to-air shift in spectral characteristics becomes minimum when the last part of the film is deposited without any additional oxygen. Further experiments are in progress to minimize this effect.

14. Conclusion

We have investigated various process-dependent properties of the ZrO₂-MgO solid solution composite films deposited by reactive electron-beam evaporation. Substrate temperature and oxygen pressure affect the optical properties of the composite films in a very interesting manner. This is probably due to the formation of superstoichiometric structures in the films above a certain threshold value of oxygen pressure. SEM analysis has indicated the presence of a high ratio of oxygen in the films deposited at higher pressure. The optimum quantity of MgO in ZrO₂ needed to produce the highest refractive index is also determined by SEM measurements. The x-ray diffraction analysis showed various interesting results. Although most of the films showed cubic structure, the films deposited at ambient conditions reveal the presence of a small amount of monoclinic phase. This phase is also indicated by the indirect bandgap analysis. The refractive index reached its highest value for the films deposited at 167 °C without any additional oxygen. Films deposited at a temperature of 125 °C showed the highest refractive index when deposited at an oxygen pressure of 1 × 10⁻⁴ mbar. At higher oxygen pressure, the films had refractive indices very similar to low-index film materials. Using suitable modulation of oxygen during the growth process made it possible to produce various types of optical coatings. The advantage of such coatings over their multilayer counterparts is the absence of discrete interfaces that are often the source of light-scattering defects. In addition, the standing-wave electric-field distribution of incident optical radiation does not encounter any discrete changes; this leads to higher damage threshold of such devices.

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